

DOCKET NO.: MV03-010
Application No.: 10/715,699
Office Action Dated: March 17, 2008

PATENT
REPLY FILED UNDER EXPEDITED
PROCEDURE PURSUANT TO
37 CFR § 1.116

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Scott Alan Geye, et al.

Confirmation No.: **5395**

Application No.: **10/715,699**

Group Art Unit: **2195**

Filing Date: **November 18, 2003**

Examiner: **Meng Yao Zhe**

For: **AFFINITY MASK ASSIGNMENT SYSTEM AND METHOD FOR
MULTIPROCESSOR SYSTEMS**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please Enter
/M.Z./

REPLY PURSUANT TO 37 CFR § 1.116

In response to the Official Action dated **March 17, 2008**, reconsideration is respectfully requested in view of the amendments and/or remarks as indicated below:

- ☐ **Amendments to the Specification** begin on page _____ of this paper.
- ☒ **Amendments to the Claims** are reflected in the listing of the claims which begins on page 2 of this paper.
- ☐ **Amendments to the Drawings** begin on page _____ of this paper and include an attached replacement sheet.
- ☒ **Remarks** begin on page 8 of this paper.
- ☒ The Commissioner is hereby requested to grant an extension of time for the appropriate length of time, should one be necessary, in connection with this filing or any future filing submitted to the U.S. Patent and Trademark Office in the above-identified application during the pendency of this application. The Commissioner is further authorized to charge any fees related to any such extension of time to Deposit Account No. 23-3050.